

IN THE ABSTRACT

The invention relates to a device (1) which is used for the non-invasive detection of the properties of a medium by means of interferometry. The inventive device (1) comprises: an optical source (3) which is used to illuminate at least one zone of the medium that is to be probed (34) with a light beam (19); and an interferometer (5) which is used to split the light beam (19) into a reference beam (21) and a probe beam (23), said interferometer (5) having a cutoff frequency f_c for the automatic control of the respective lengths of the reference beam (21) and the probe beam (23). The device (1) also comprises scanning means (33) which, together with the probe beam (23), are used to scan the zone to be probed (34) at a frequency f (frequency of the acquisition of images recorded by the means for measuring variations in the phase of the light beam (7)) greater than the cutoff frequency f_c .